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Bib Data Sheet

CONFIRMATION NO. 1815

SERIAL NUMBER 10/014,855	FILING DATE 12/14/2001 RULE	CLASS 414	GROUP ART UNIT 3652	ATTORNEY DOCKET NO. 217406US2	
APPLICANTS Masanori Tateyama, Kumamoto-Ken, JAPAN; Akira Miyata, Kumamoto-Ken, JAPAN;					
** CONTINUING DATA *****					
** FOREIGN APPLICATIONS ***** JAPAN 2000-380663 12/14/2000					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/14/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
Verified and Acknowledged Examiner's Signature _____ Initials _____					
ADDRESS 22850					
TITLE Substrate processing system and substrate processing method					
FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		